

Docket No.: 3079D-0214

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Jin Sheng LAI

U.S. Patent Application No. 10/798,868

Filed: March 12, 2004

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Confirmation No. 6614

Group Art Unit: 2828

Examiner: Patrick Stafford

For: CONTROL AND COMPENSATION METHOD FOR LASER OUTPUTTING

Response to Notice of Non-Compliant Amendment (37 CFR 1.121)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of March 19, 2008, please amend the above-identified application as follows: